

Neuchatel

Transformation from Watch Industry to MEMS-based Cluster

Role of Universities

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Sensors, Actuators and Microsystems Laboratory

Institute of Microtechnology

University of Neuchatel, Switzerland

EPFL-STI-IMM

[*www-samlab.unine.ch*](http://www-samlab.unine.ch)

Outline

- *Introduction*
- *Consumer Products (watches)*
- *Microfluidic Dispensing Systems*
- *Chemical Sensors*
- *Tools for Nanoscience*
- *Optical MEMS*
- *Power MEMS*
- *Concluding remarks*

University Role/Mission

- ***Education***
 - ***Bachelor, Master, PhD Program***
- ***Conduct Fundamental and/or Applied Research***
- ***Applied Research***
 - ***University/Industry Collaboration***
 - ***“Successful” Research : Technology Transfer***
 - ***Independent Research***
 - ***“Successful” Research : Technology Transfer
Start-up Companies***
 - ***Intellectual Property Right (IPR)***
 - ***Incubators (NEODE)***

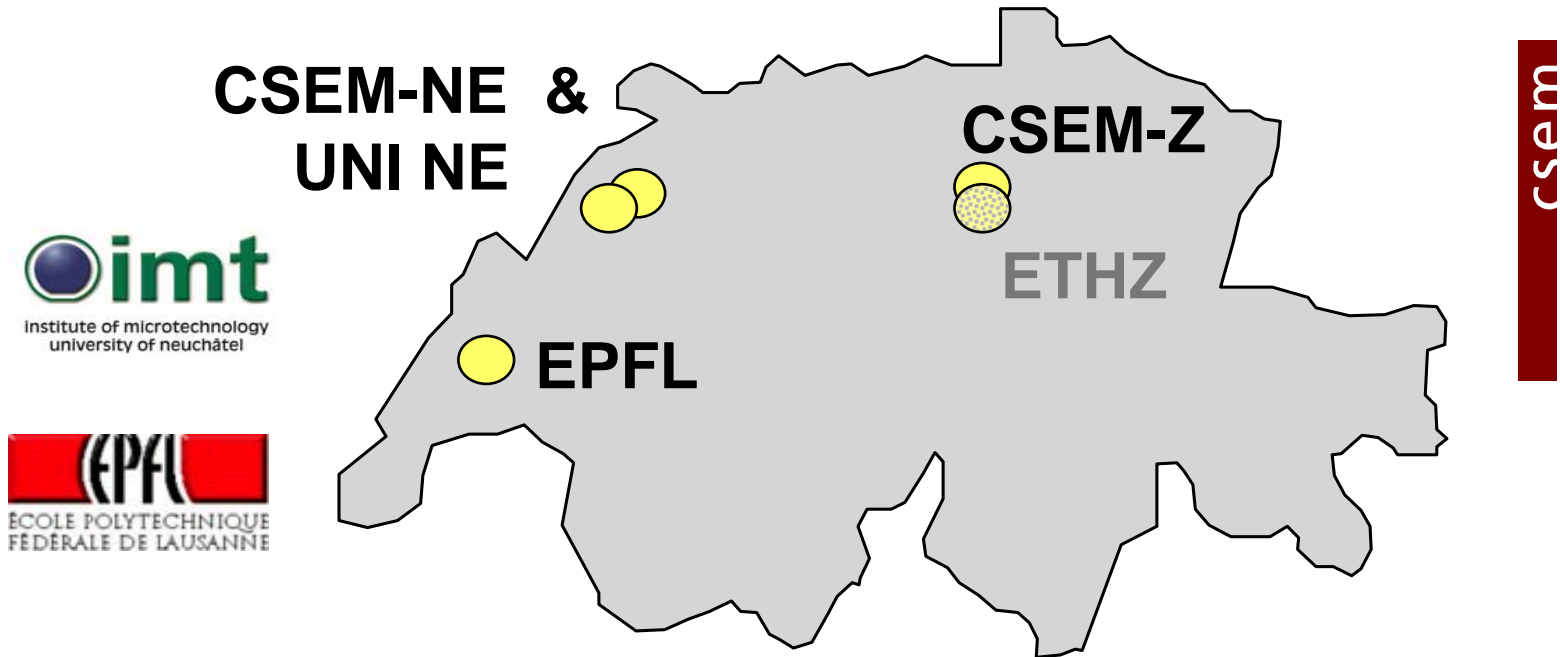
Institute of Microtechnology

University of Neuchâtel (IMT UniNE)

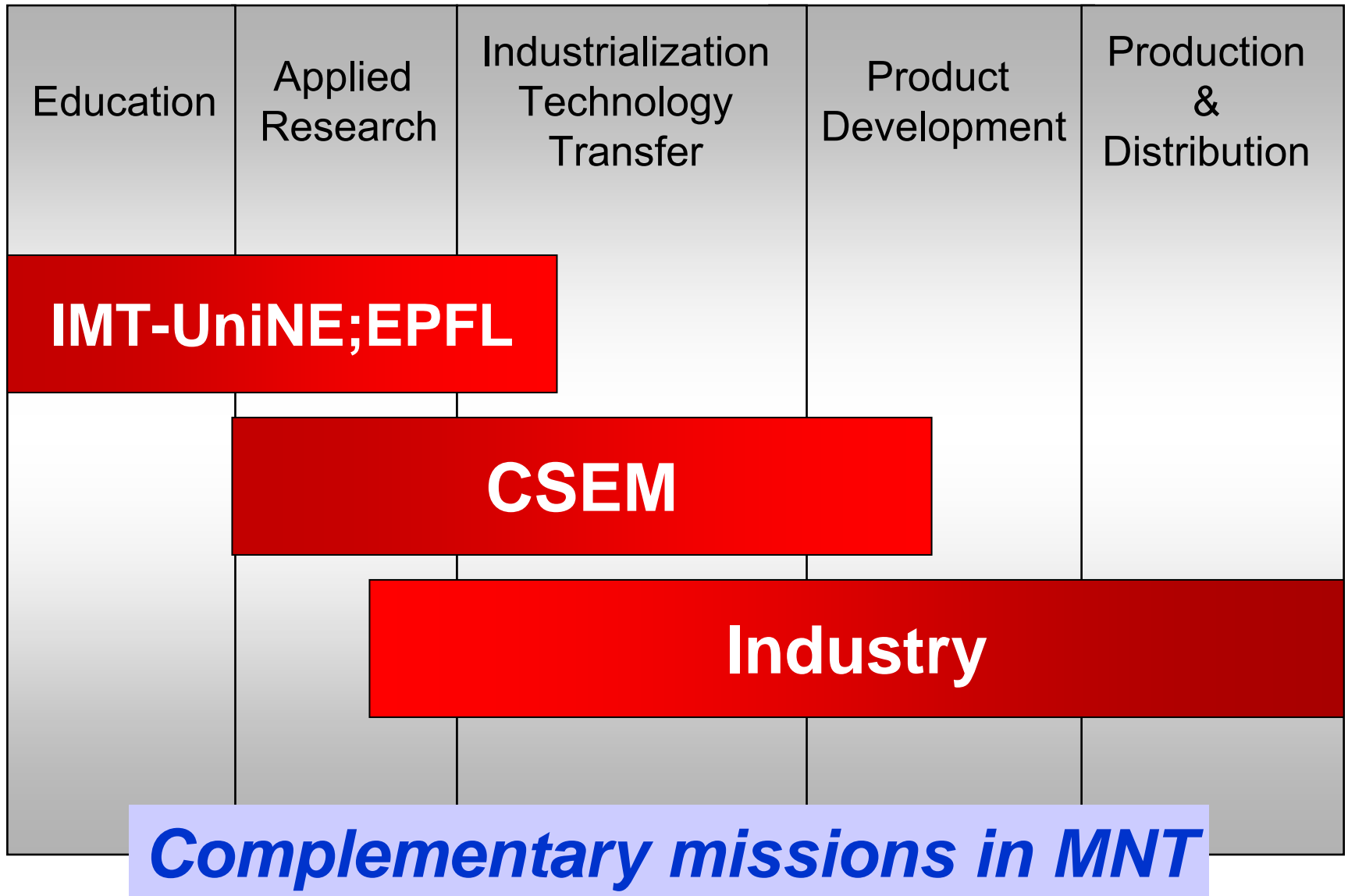
- ***IMT UniNE started its activities in 1975***
- ***The Jurassic Arc was in an economic crisis, due to massive job losses in the mechanical watch industry (arrival of the quartz watch)***
- ***IMT UniNE's original mission:***
 - Education***
 - Applied Research***
 - Support Local Industry***

Regional Network in MNT

Joint efforts for education and research in the fields of Micro- and Nanotechnology (MNT)



Goal: Benefit from the complementary strengths of the members



Mission of the “Pôle”

- ***Collaboration in educational programmes***
- ***Dual appointments for selected key people***
- ***Establishment of joint research programs***
- ***Co-ordination of investments in laboratory equipment***
- ***Joint research laboratories: CMI and ComLab***
- ***Joint industry cont(r)acts***

Power MEMS

**Consumer Products
*Sensors/Actuators***

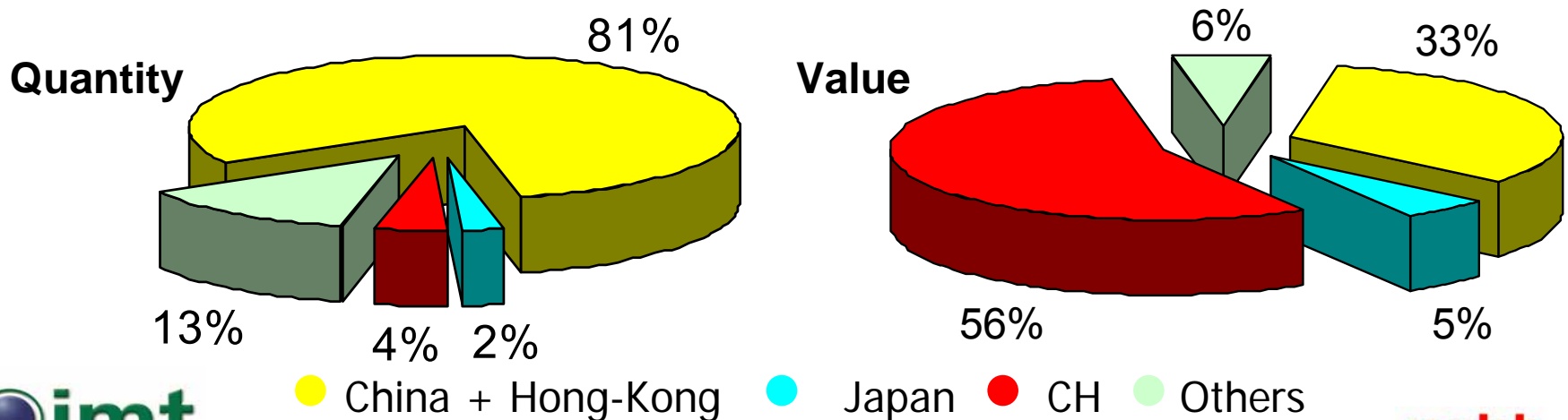
**Telecommunication
*Optical MEMS***

**Life-Sciences
*Bio-MEMS***

**Advanced Instruments
*Nano-Tools***

**Life-Sciences
*Micro-Fluidics***

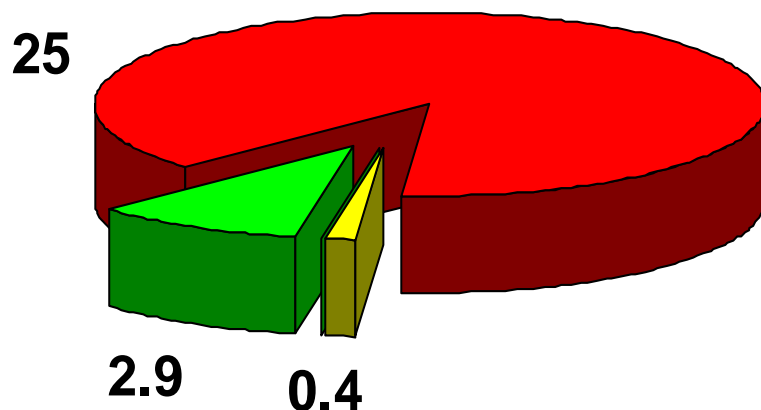
- Watches, movements and components (globally):
 - 1.5 Billion pieces / year
 - 16 to 17 Billion CHF 1 CHF ≈ €0.64; 1 CHF ≈ US\$ 0.80 ; 1CHF ≈ ¥87
- Switzerland:
 - 120 Mio. watches, movements and components
 - 28 Mio. finished watches = 10.5 Billion CHF
 - Average export price: 362 CHF (J: 30 CHF / HK: 7CHF)
- Global Production of finished watches:



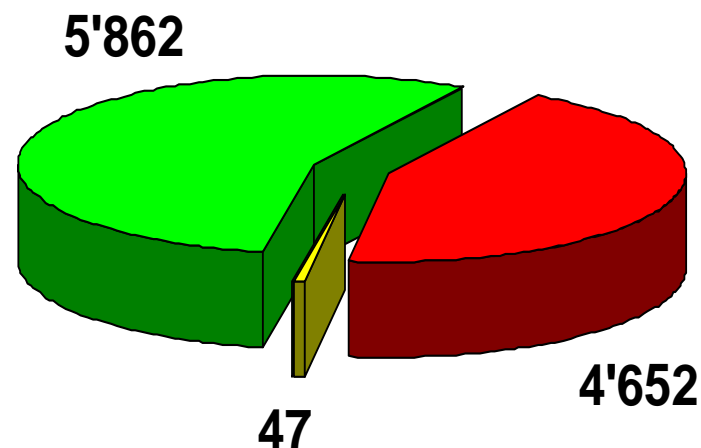
Swiss Export of Finished Watches

For 2002 / Source: www.fhs.ch

Pieces (in Mio.)



Value (in Mio. CHF)



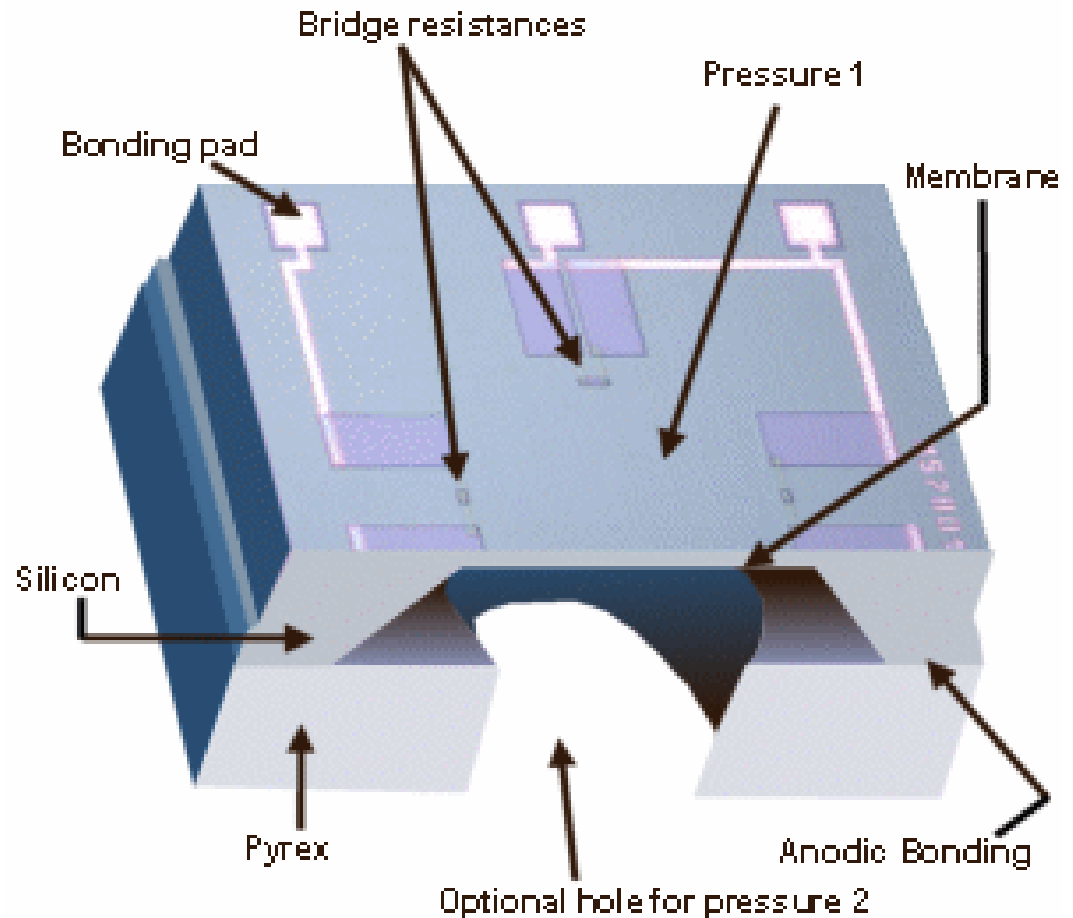
● Mechanical

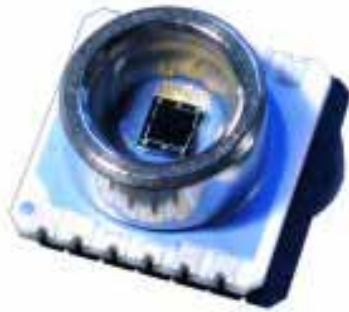
● Quartz anal.

● Quartz digit.

Process features:

- Implanted piezoresistors
- Precise electrochemical etch stop
- Anodic Bonding





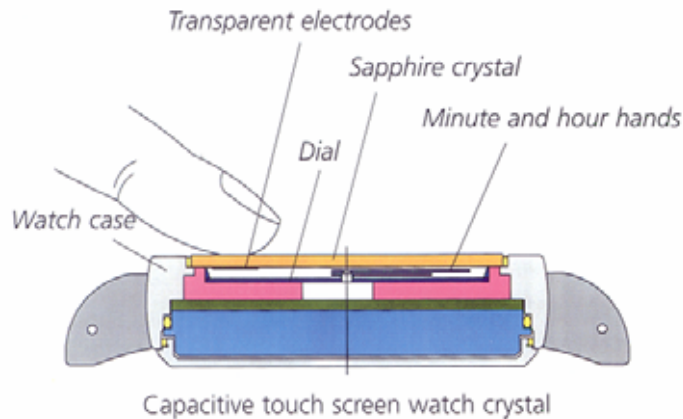
- **Altitude variation of 1 m:**
 - $\sim 0.1 \text{ mbar} \equiv \sim 150 \text{ pm}$
- **Resolution:**
 - $\sim 3 \mu\text{bar} \equiv \sim 3 \text{ cm}$ altitude variation
- **Sensor power consumption:**
 - $\sim 1.3 \mu\text{W}$



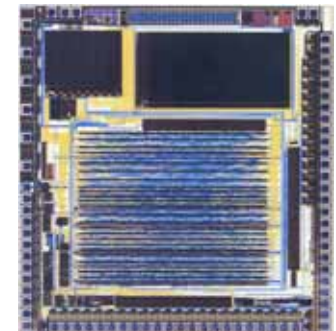
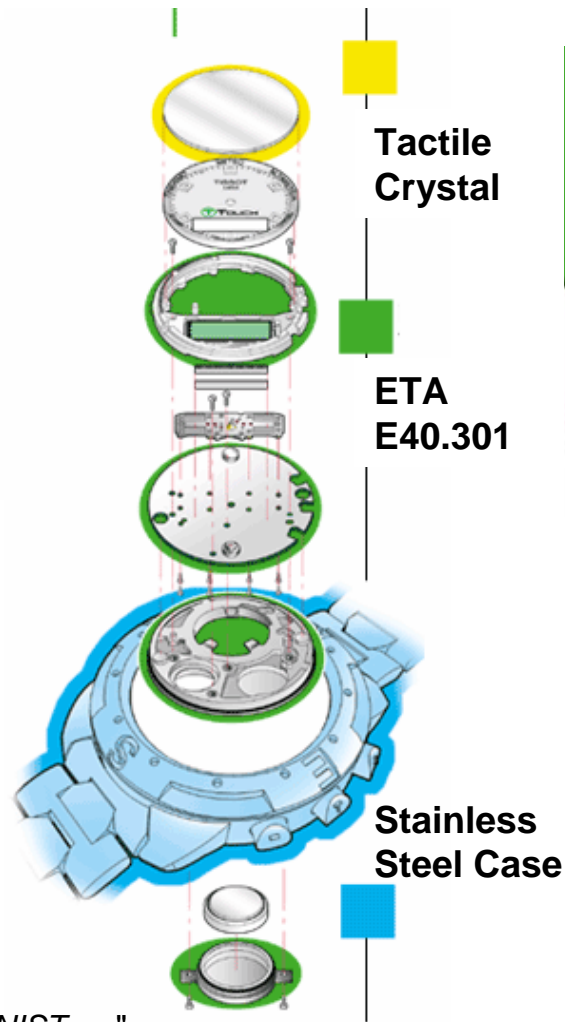
Tissot T-Touch (Tactile Crystal)

ASULAB

A COMPANY OF THE  **SWATCH GROUP**



- User interface by tactile capacitive touch screen
- Altimeter
- Weather forecast
- Temperature (with US/EU Units)
- Compass, chrono, alarm



C. Germiquet, R. Dinger et al., "ALPINIST, ...",
Proc. Société Suisse de Chronométrie, Le Sentier, (Oct. 1999)

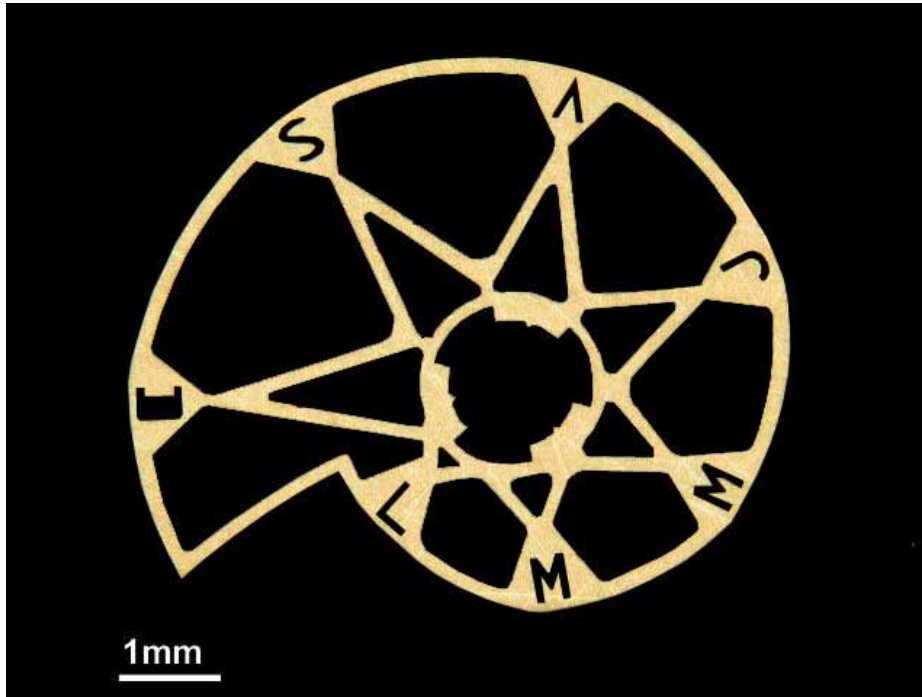
www.asulab.ch

Mechanical Watches



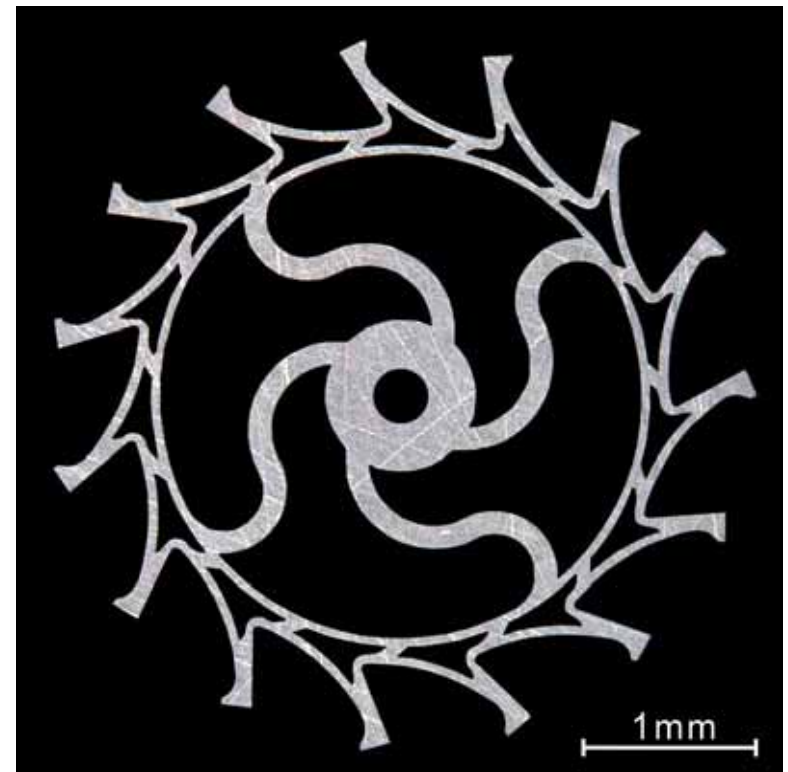
- *M.Despont, H. Lorenz, N. Fahrni, J. Brugger, P. Renaud, P. Vettiger, “High aspect ratio ultrathick, negative-tone near-UV photoresist for MEMS applications”, Proc. IEEE MEMS, Nagoya 1997, pp. 518-522.*
- *H. Lorenz, M. Despont, P. Vettiger, P. Renaud, “Fabrication of photoplastic high-aspect ratio microparts and micromolds using SU-8 UV resist”, Microsystem Technologies, 4 (1998), pp. 42-47.*

Watch microcomponents



Cam of the days

Escape-wheel



Why Single Crystal Silicon ?

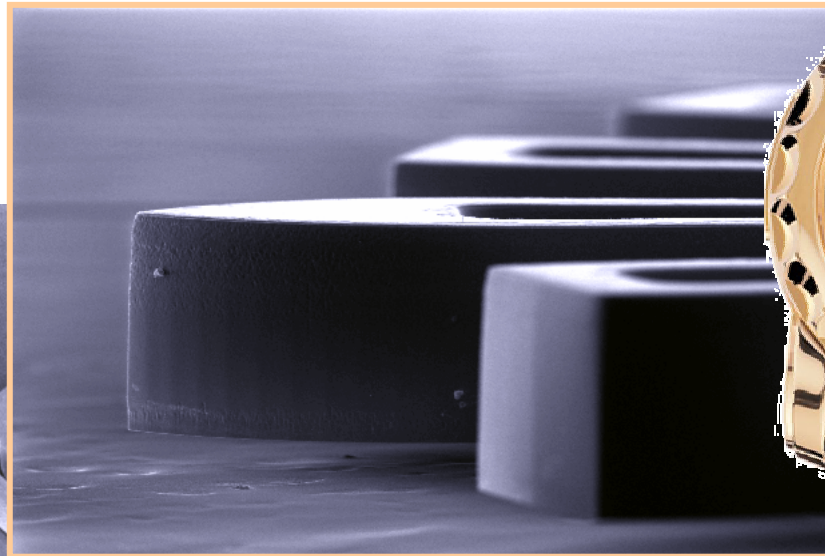
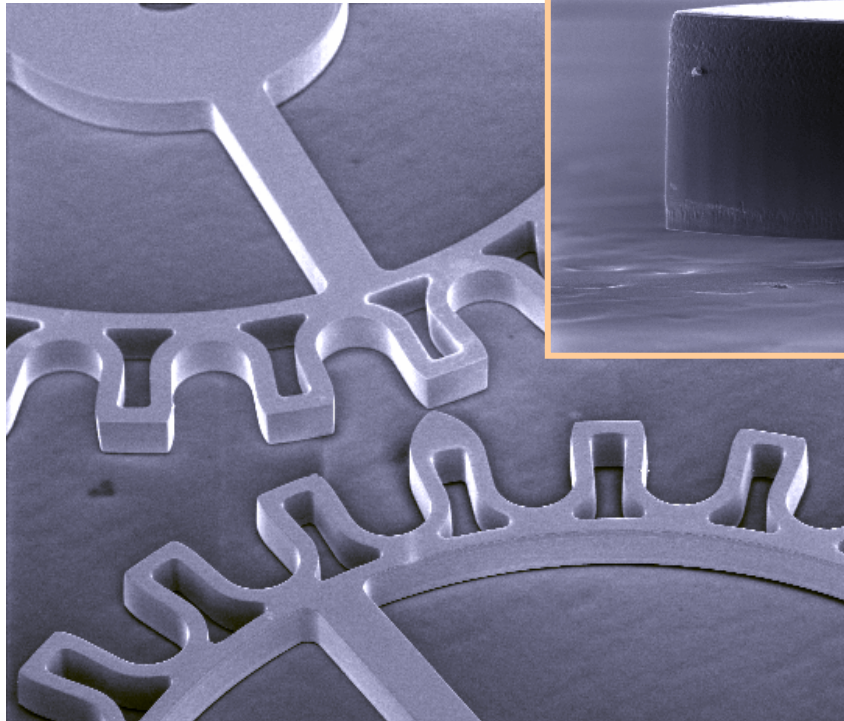
- Kurt Petersen, "*Silicon as a Mechanical Material*", Proceedings of the IEEE, vol.70, no.5, May 1982, pp. 420-57.
- Well-known and controlled properties
- Low density (2.33), amagnetic, electrical conductor, easy to overcoat, ...
- Machining by Deep Reactive Ion Etching (DRIE).

Elastic behavior of Silicon

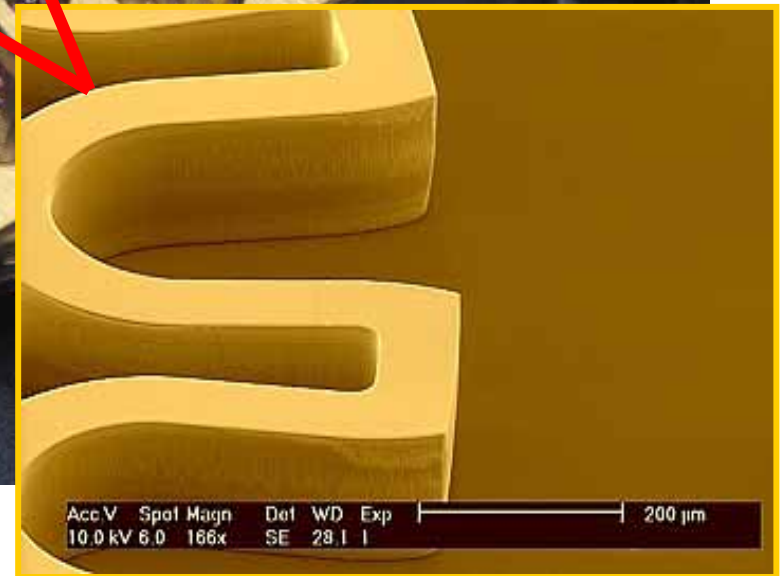
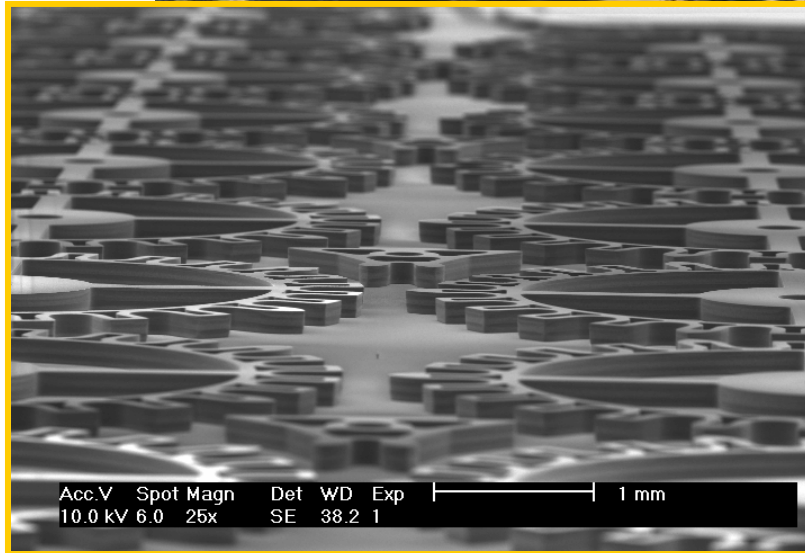
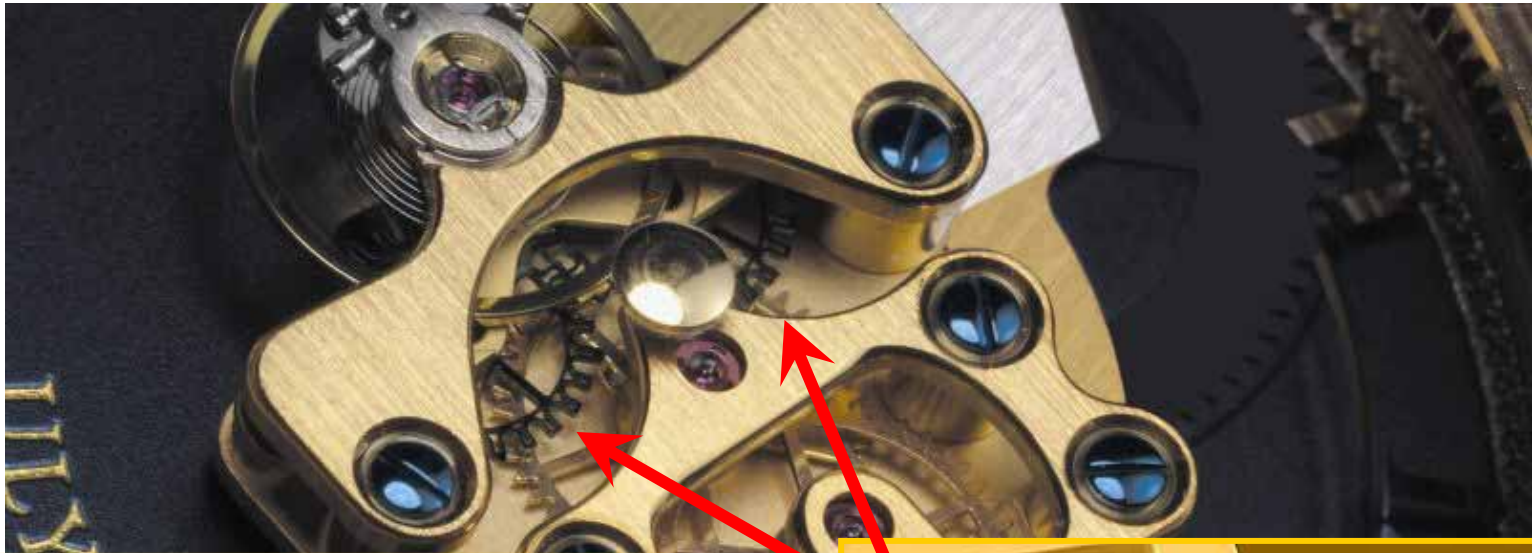


Silicon Structures of Watch Components

- Machining of complex mechanisms with sharp edges
- Reduced friction
- Higher lifetime



Dual Wheel Escapement with Si-Wheels



Dual Wheel Escapement with Si-Wheels

- Complex silicon wheels with stopper teeth
- Reduced friction
- Reduced moment of inertia



MST based instruments

Spin-off Activities:
μfluidics
chemical sensors
lab-on-chip

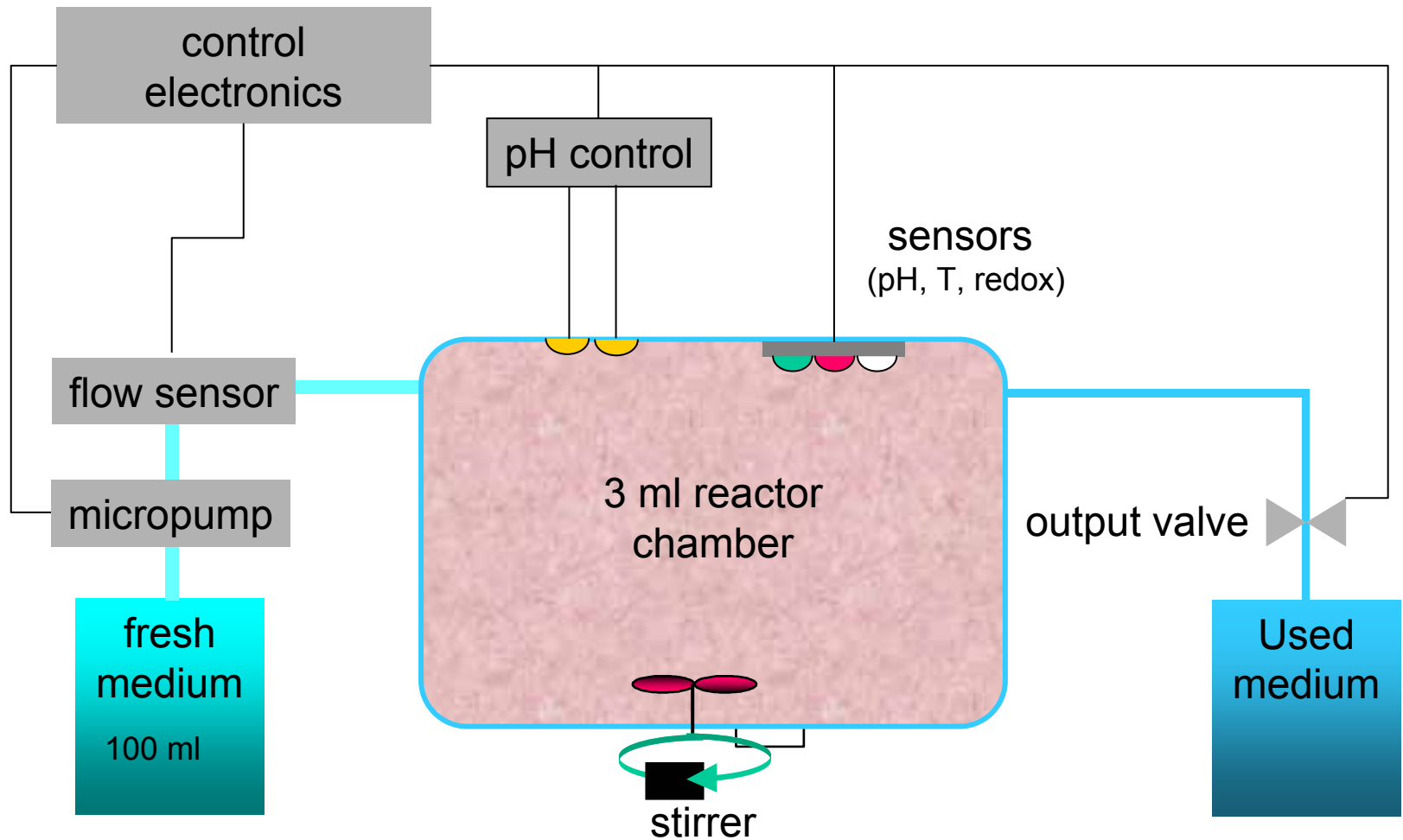
Life Sciences : Space Bioreactor

Built to evaluate the growth characteristics of yeast cells in microgravity

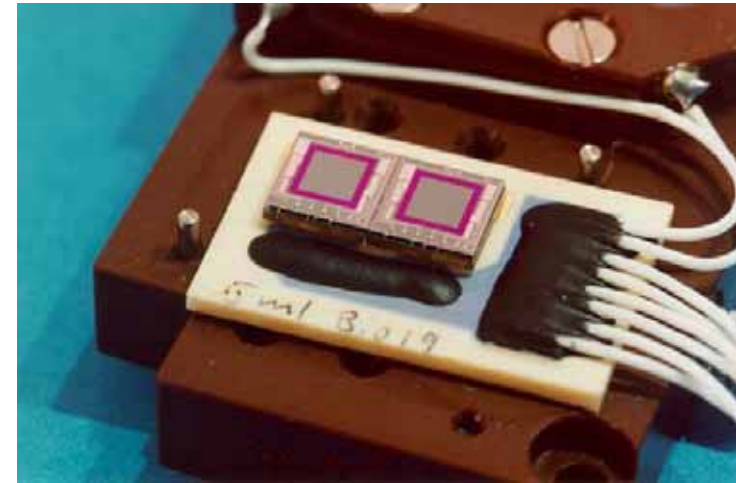
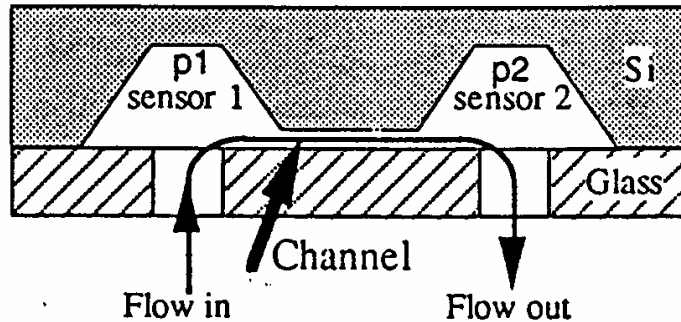
Flown by ESA onboard IML Spacelab July 1994, March 1996 and January 2003



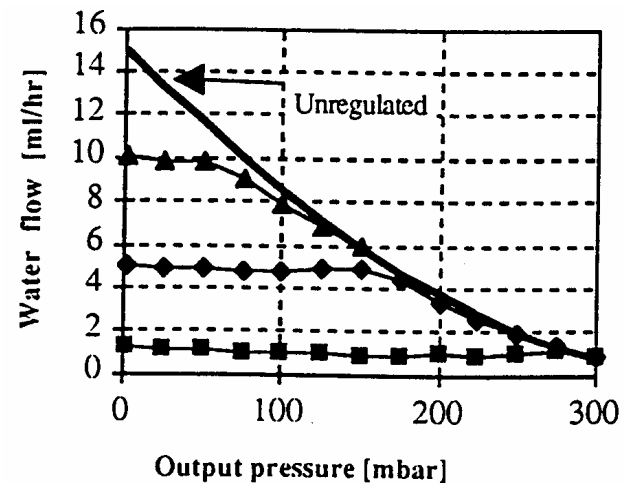
Working principle



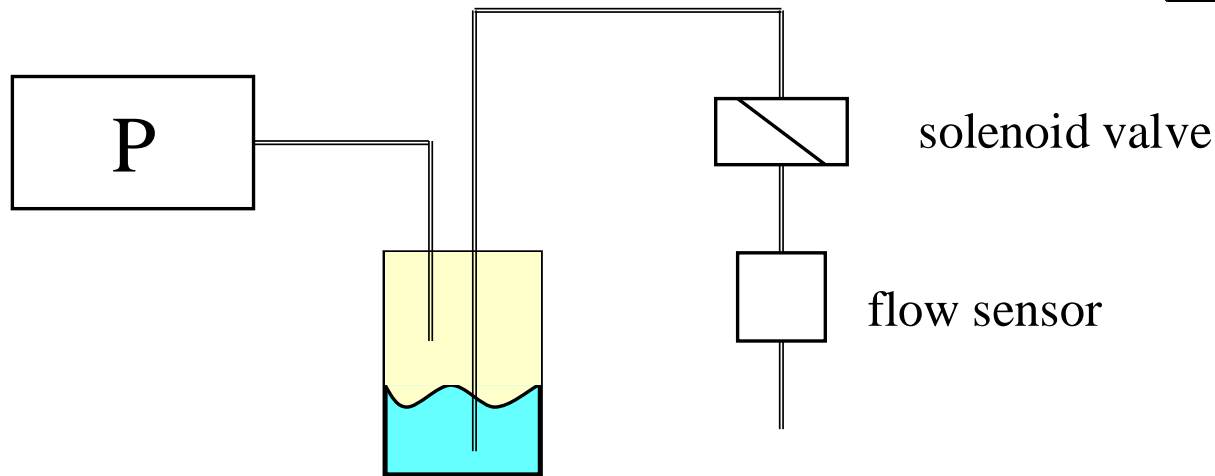
Flow Sensor



- dual piezo-resistive low pressure sensor
- $4.75 \times 9.5 \times 1 \text{ mm}^3$
- 5 mL/h full scale
- accuracy $\sim 2\%$



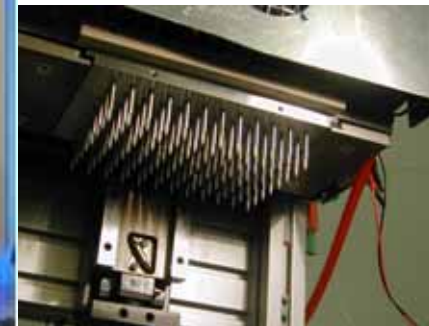
Dispensing Systems



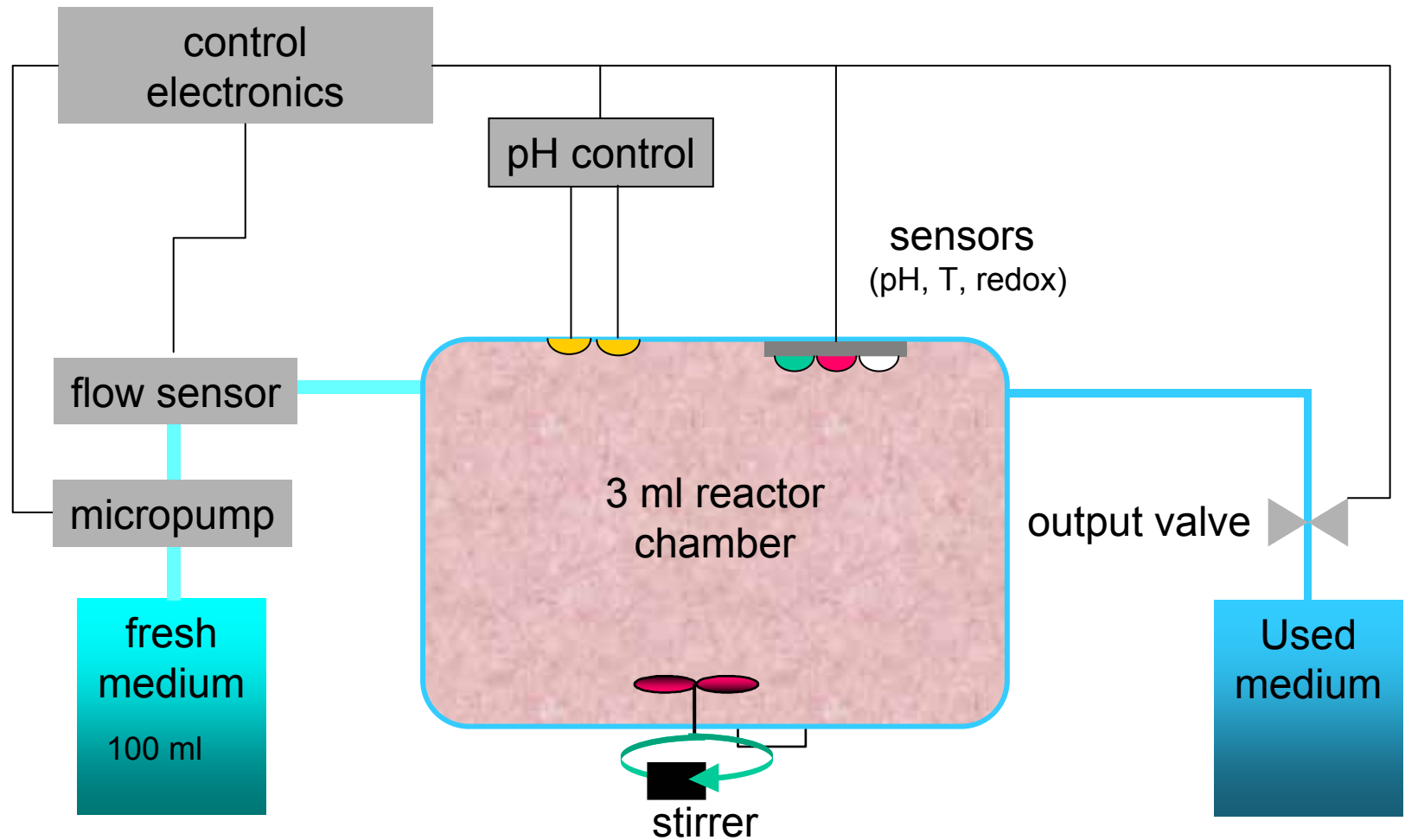
Advantages:

- ❖ *Control of the liquid quantity at the dispensing site.*
- ❖ *Direct, real time measurement of the aspirated or dispensed volume.*
- ❖ *Status/diagnostic of the system functionality (clogging, etc.).*

Sensor Controlled Liquid Handling



Working principle



single sensors pH-ISFET

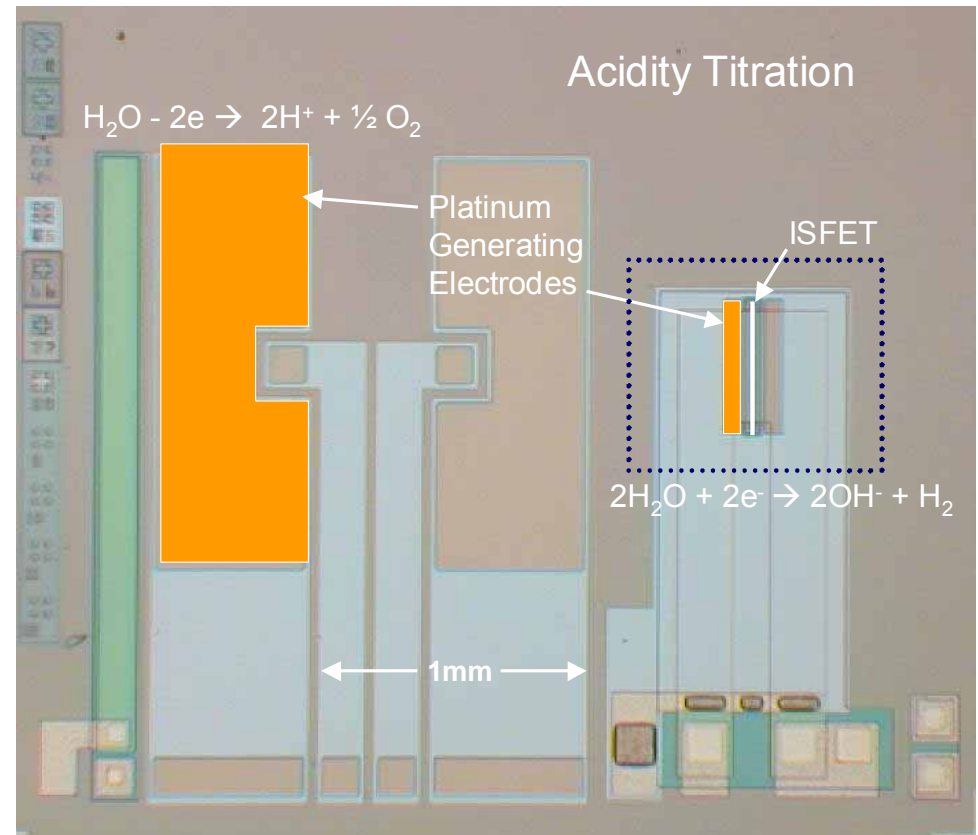
multiple sensors (pH, ORP, Conductivity, T)

(pHuture probe)

ThermoOrion



Dynamic FLASH Titration Process (1)



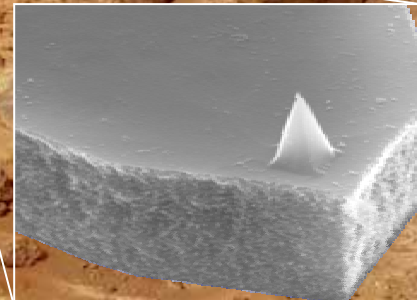
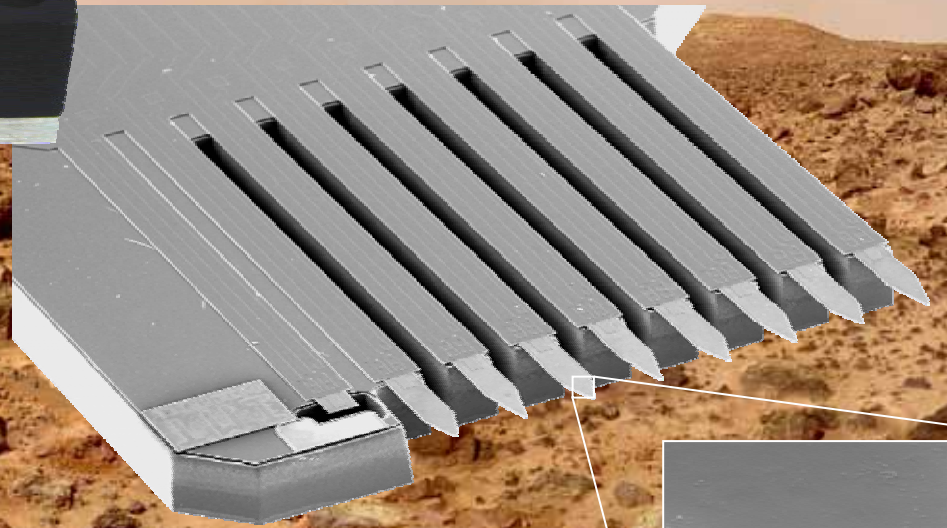
ThermoOrion *Flash Titrator*

Nanotools

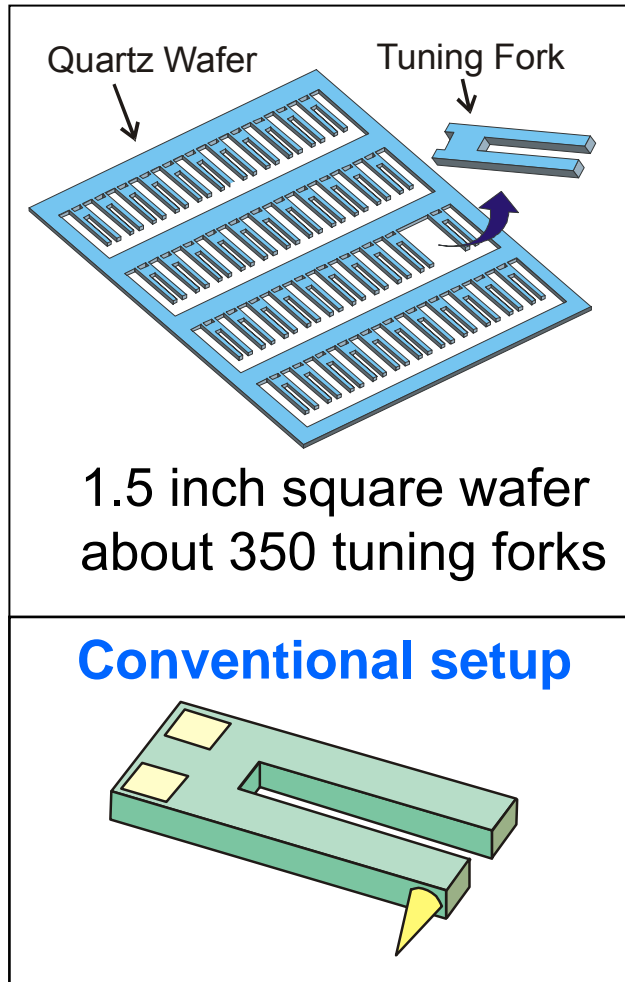
Phoenix mission to Mars: 2007



AFM on MARS

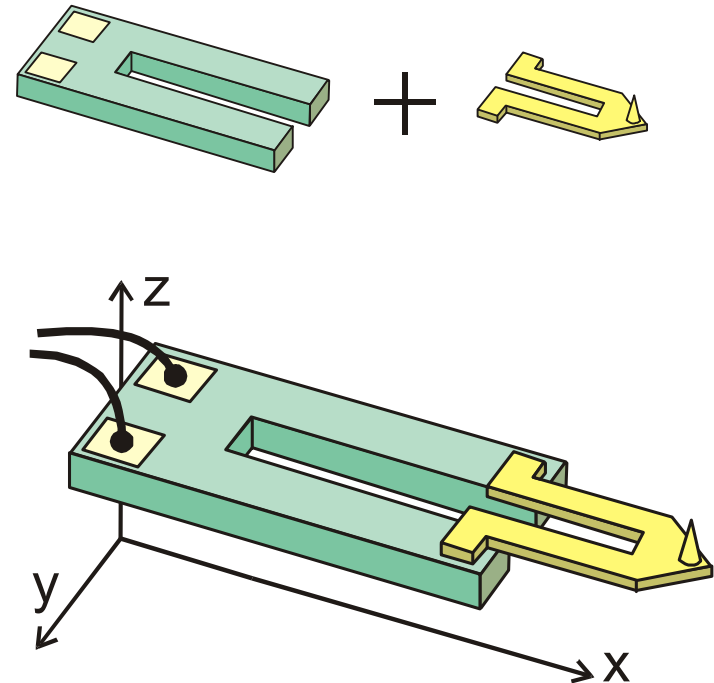


Tuning Fork based AFM Probes

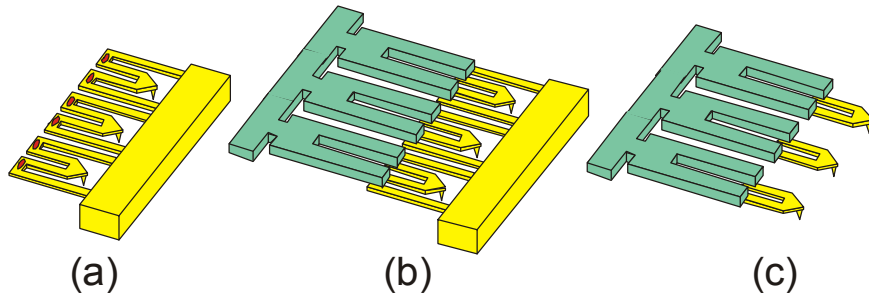


New probe concept

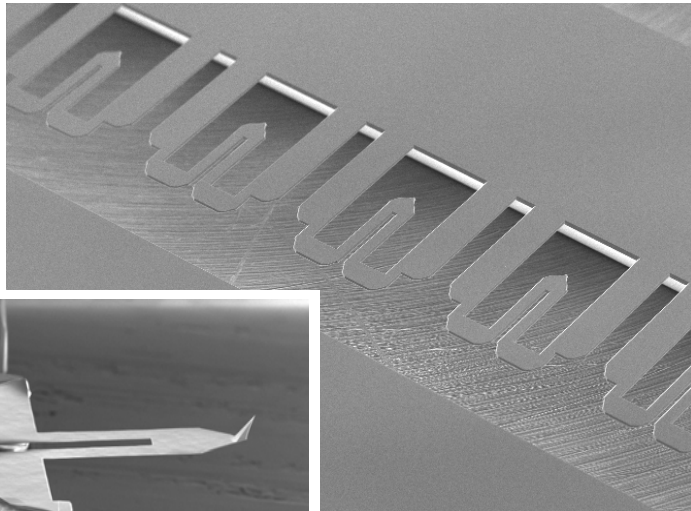
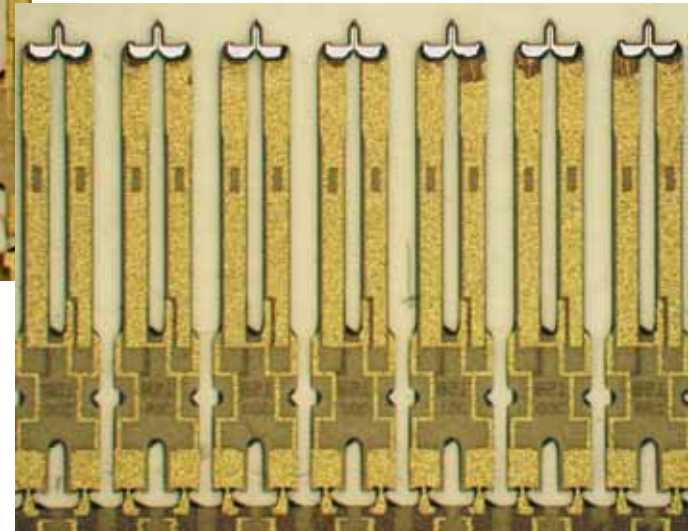
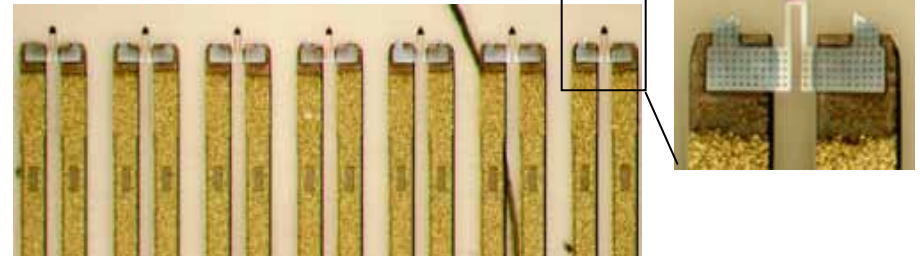
Tuning fork + Cantilever



Batch fabrication of the probe



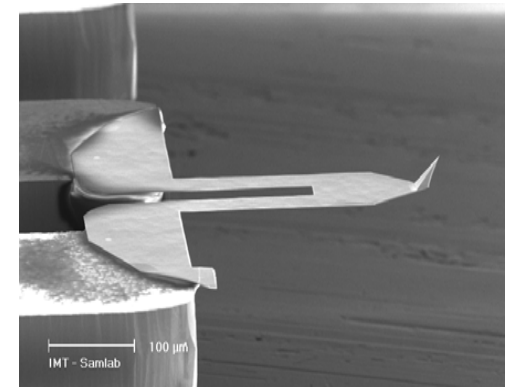
SiN cantilever
 $k = 0.01 - 1 \text{ N/m}$



Length = $125 - 700 \mu\text{m}$

Si cantilever
 $k = 1 - 550 \text{ N/m}$

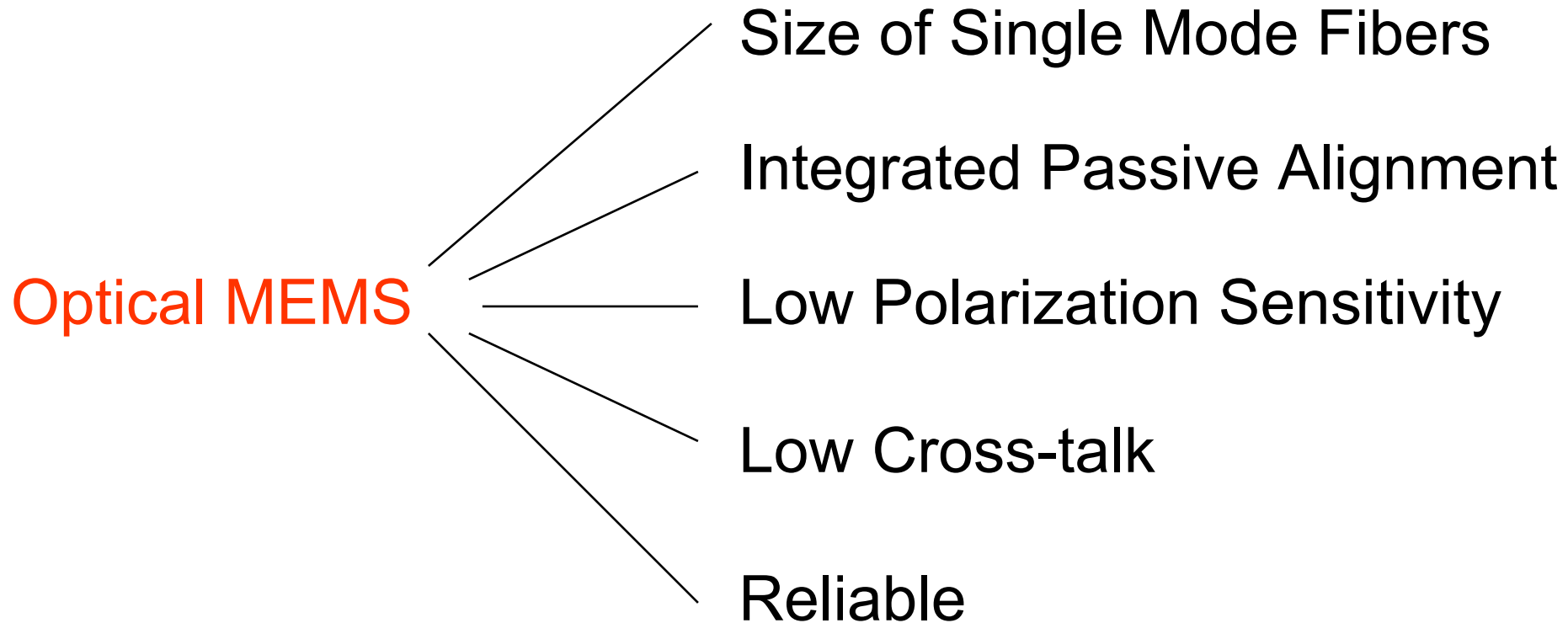
The **A**-Probe (The Akiyama Probe)



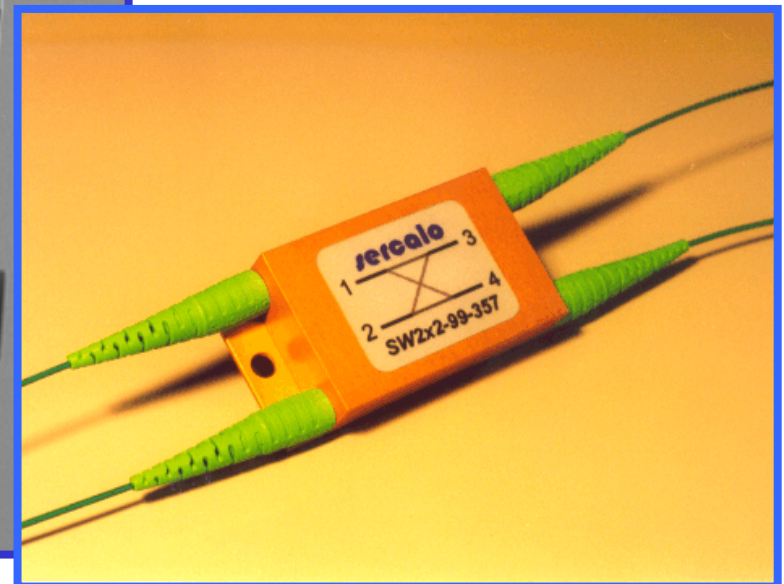
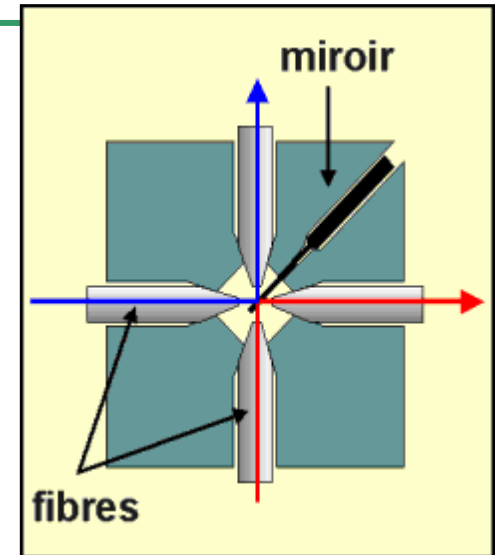
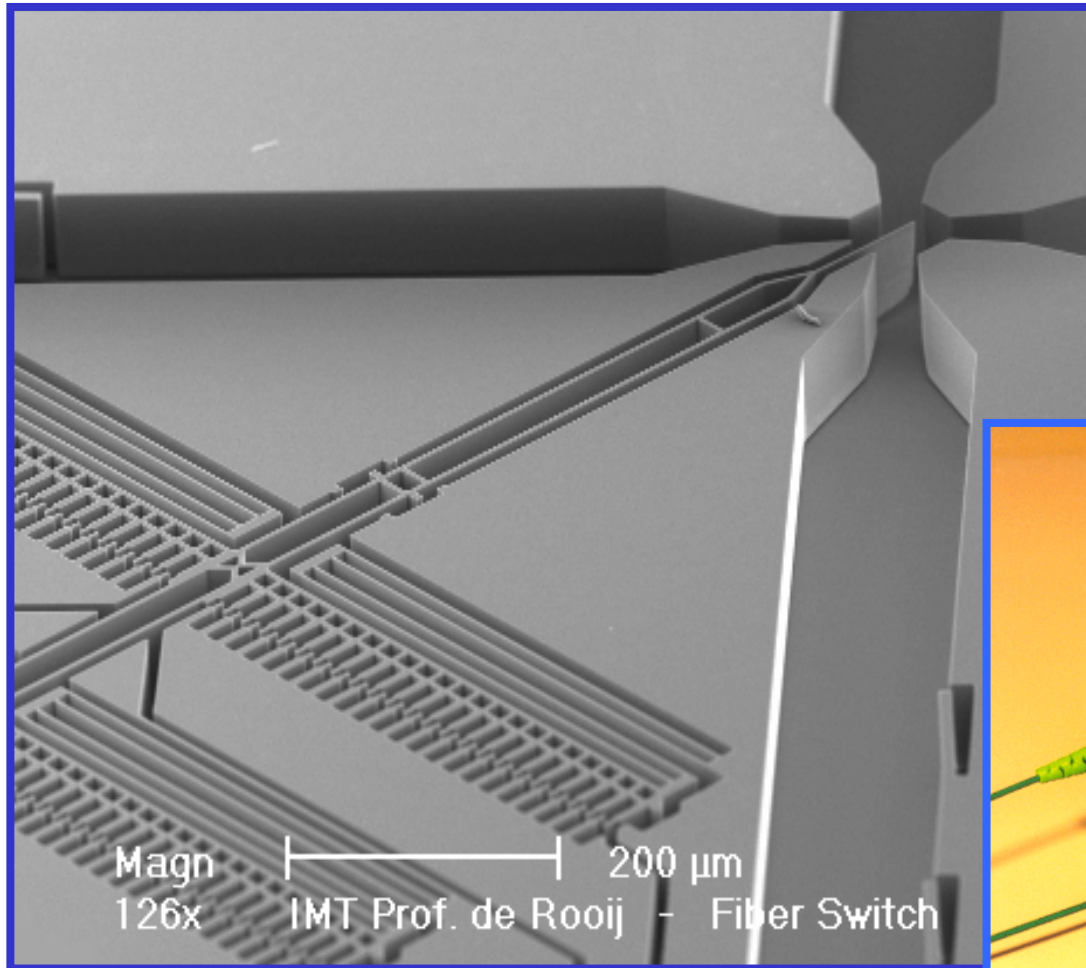
- 1. Technology Transfer initiated***
- 2. Commercialization of A-probe AFM by NanoWorld Inc.***
- 3. Development of a dedicated A-probe AFM Instrument by NanoSurf Inc.***

Optical MEMS

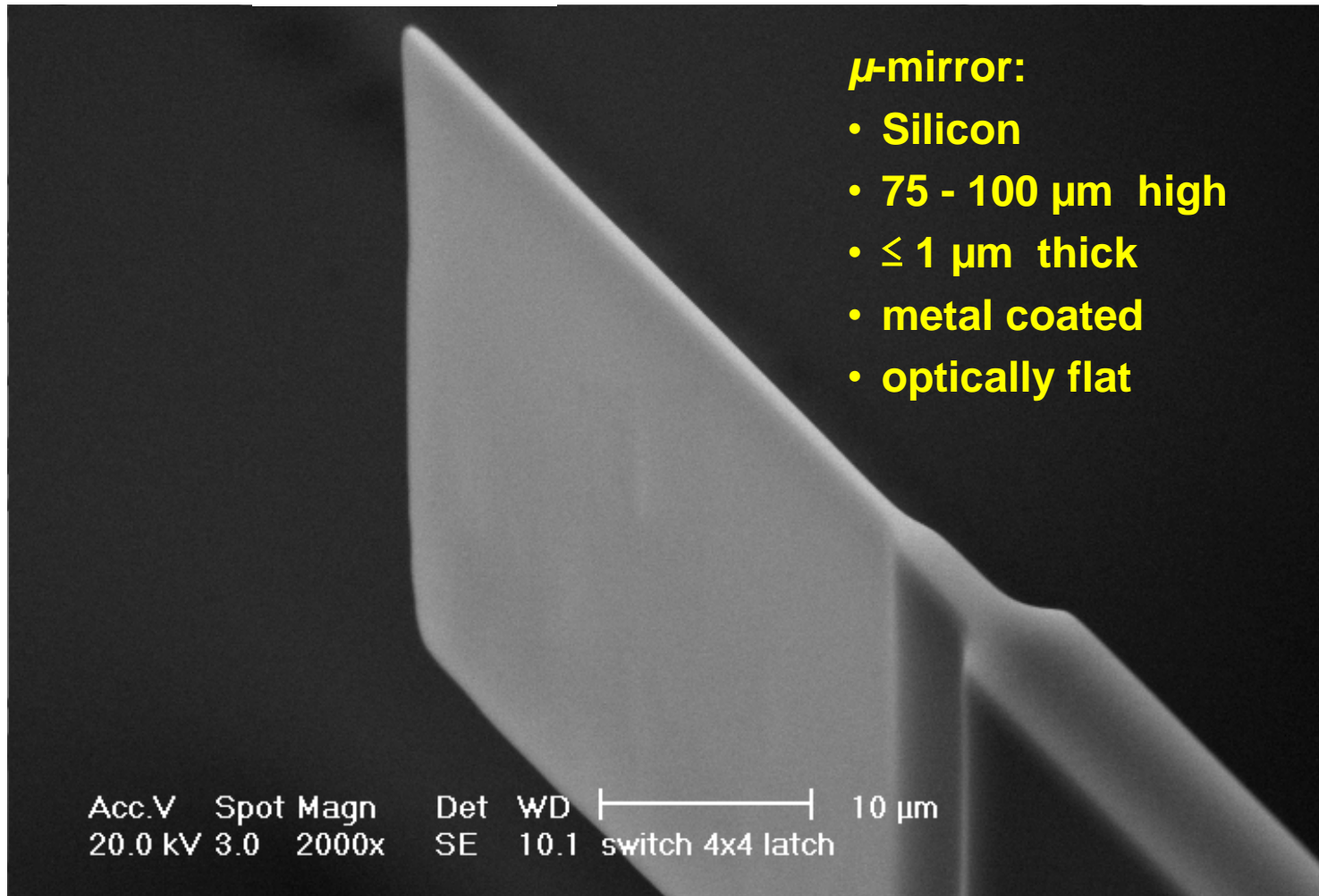
MEMS for Fiber Communication



Actuator, Grooves, Mirror



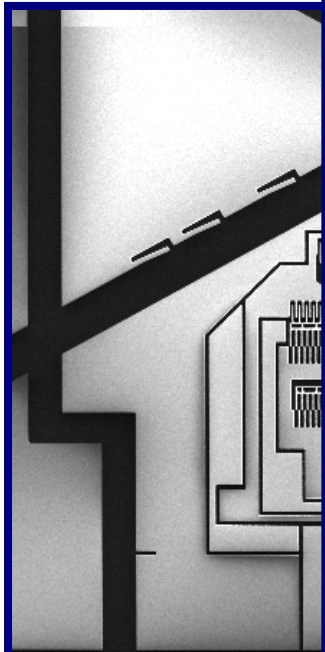
Switch Details



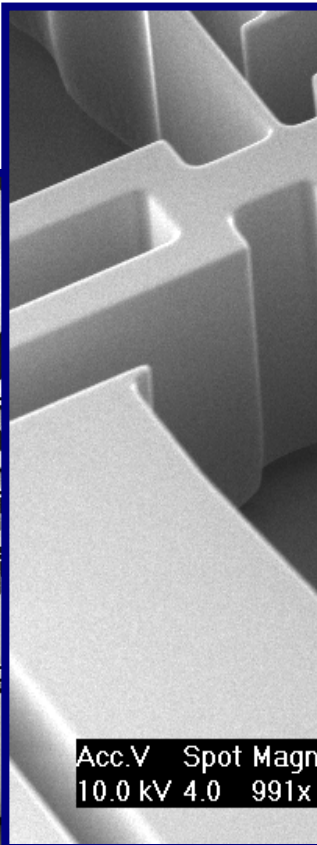
Latching Multimode Fiber 2x2 Switch

μ -mirror:

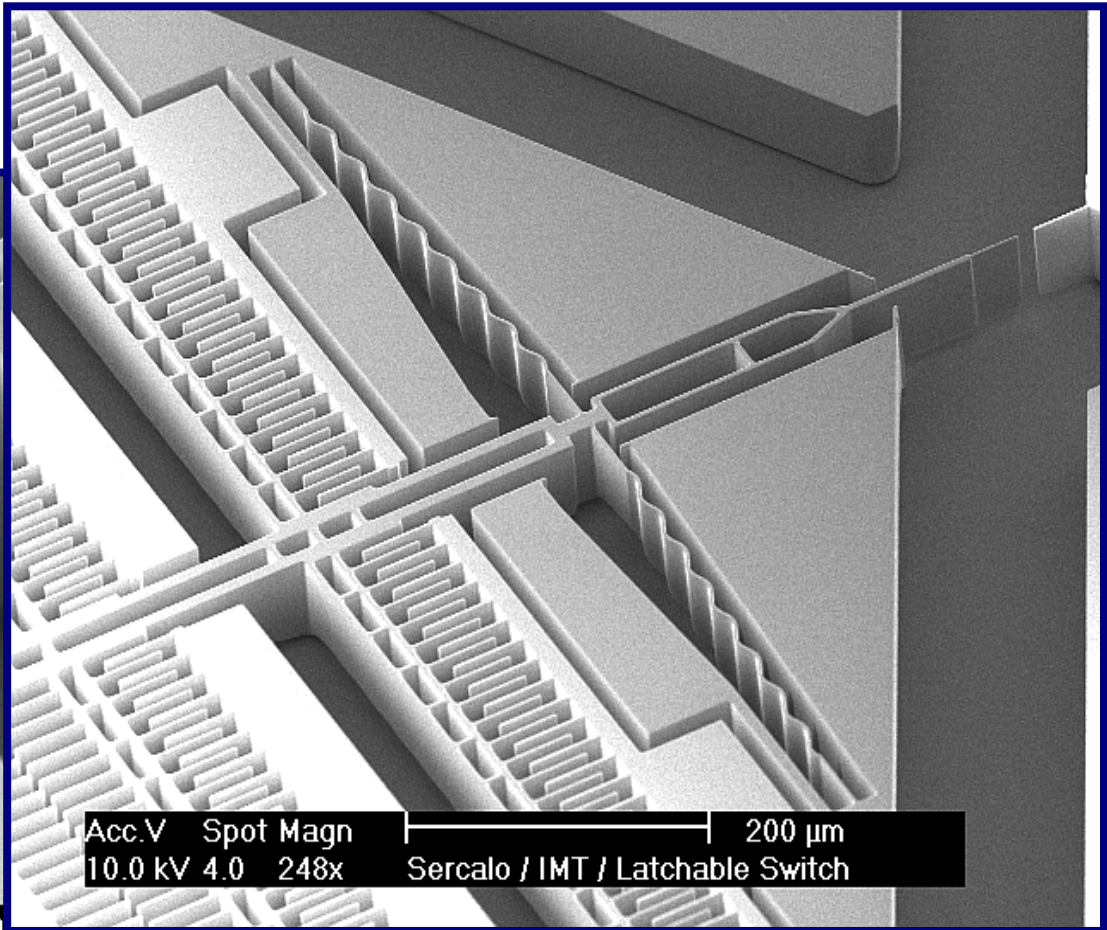
- 100 μm high
- $\leq 1 \mu\text{m}$ thick
- Gold coated



Acc.V Spot Magn
10.0 kV 5.0 65x
Sercalo / IMT / Latchable Switch

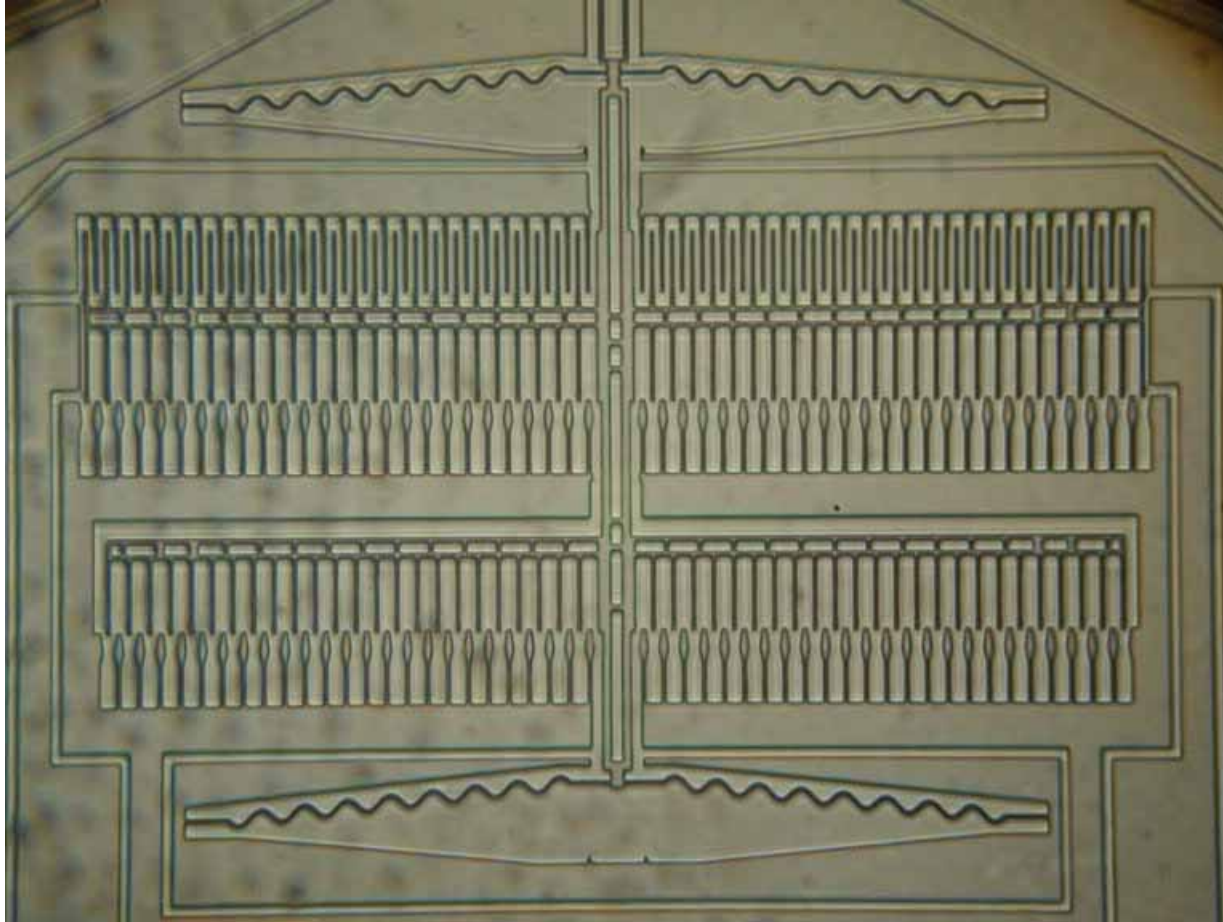


Acc.V Spot Magn
10.0 kV 4.0 991x
Sercalo / IMT / Latchable Switch



Acc.V Spot Magn
10.0 kV 4.0 248x
Sercalo / IMT / Latchable Switch

Latching on Multimode Switch



92 V



52 V

Power MEMS using Solid Propellant Based Actuators

Microthrusters for Nanosatellites/Picosatellites



<http://www.aero.org/technology/etd.html>

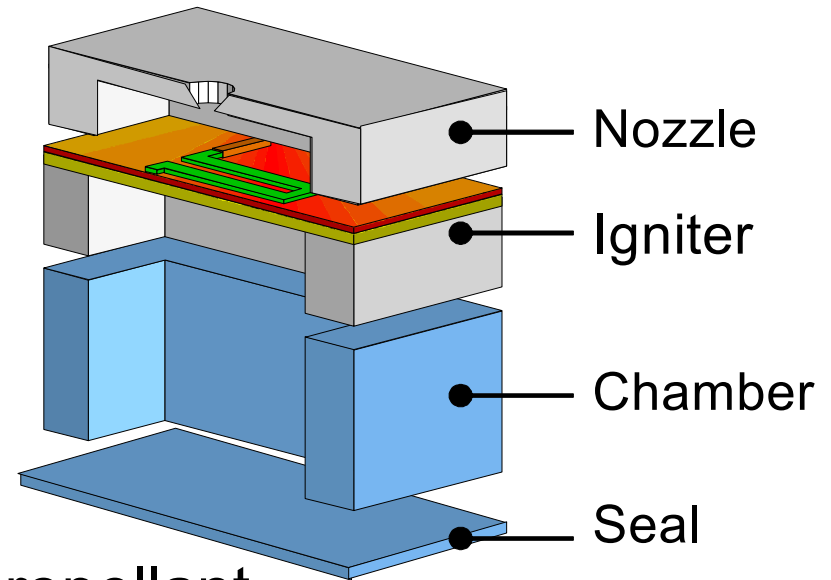
Solid Propellant Technology

- ***Combustion : large quantity of energy from small volume***
- ***Solid fuel : no leakage, stability in time***
- ***No moving parts, eliminating frictional force and making technological fabrication easier***
- ***The chamber is not pressurised, the reservoir does not need to be massive***

Microthruster : Principle of Operation

- Microthruster parts

- Nozzle
- Igniter
- Chamber
- Seal



- Operation

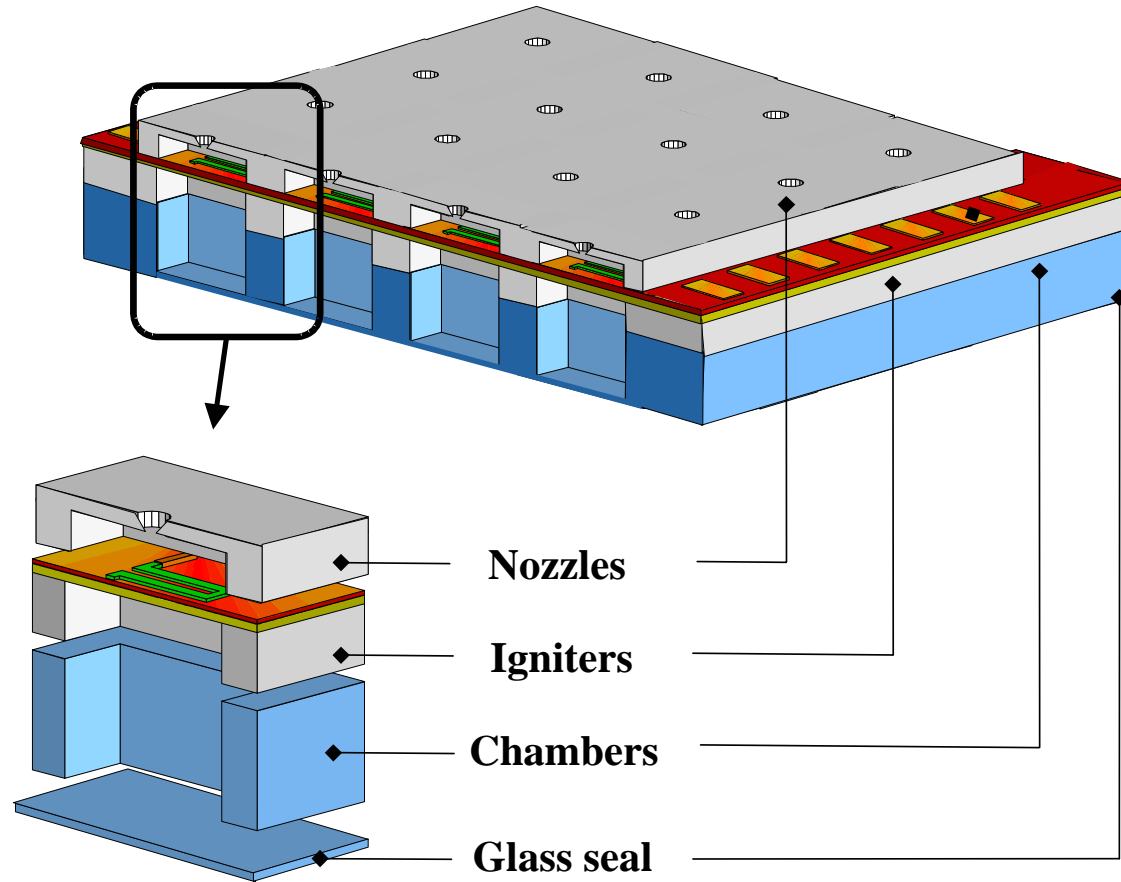
- Chamber filling with solid propellant
- Propellant heating by Joule effect and ignition
- Combustion, gas production and thrust force

- Requirements

- ignition temperature : $\sim 200^{\circ}\text{C}$

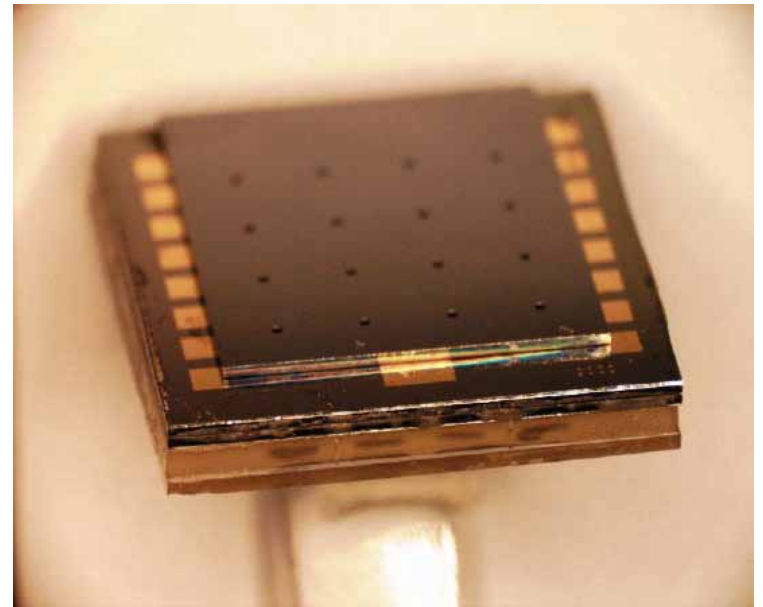
Microthruster : Principle of Operation

- Array of 4x4 microthrusters (16 thrusters)



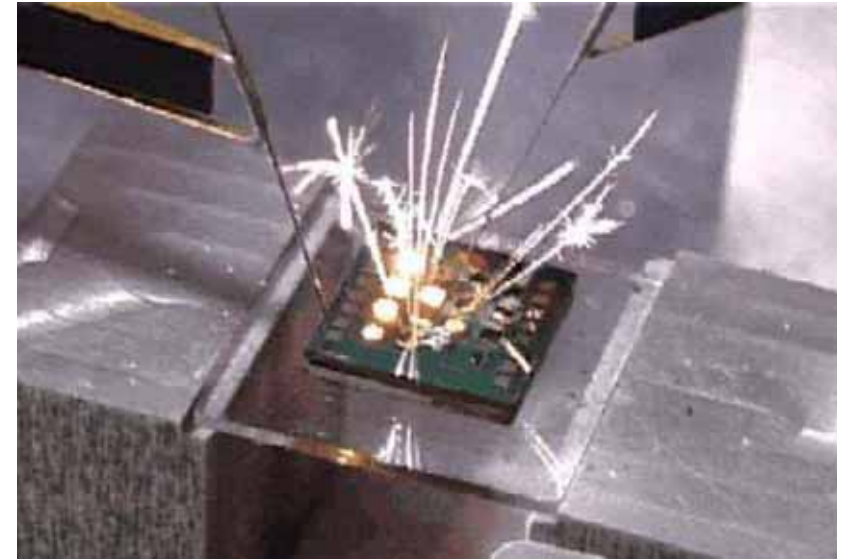
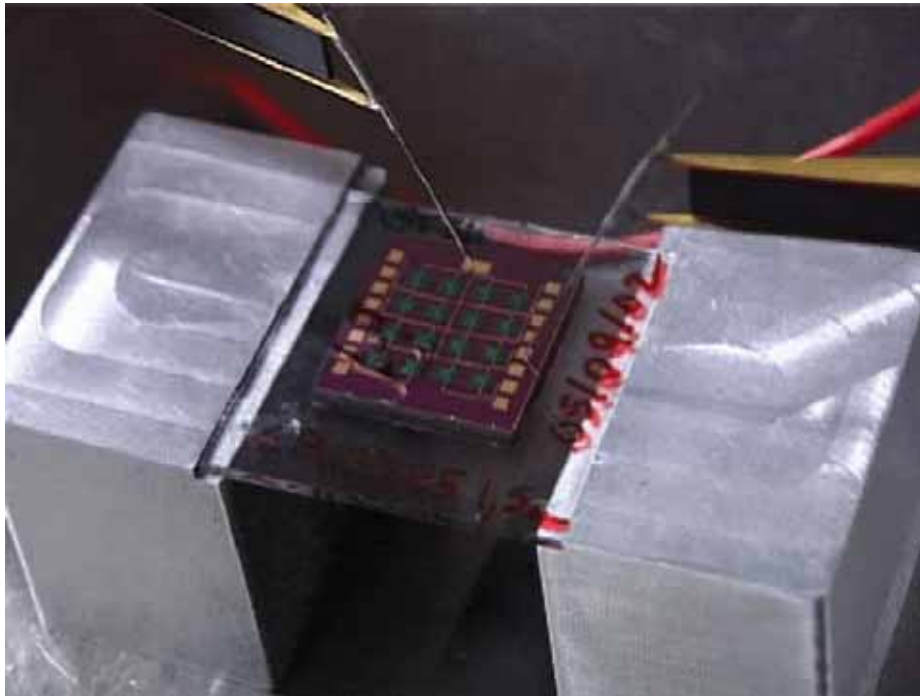
DEMO Assembling

- Filling of the parts with propellant
 - Igniter with ZPP
 - Sealed chamber with GAP
- Bonding
 - Thermal gluing (epoxy glue)
at low temperature (60-80°C)



DEMO: Ignition Tests

- Ignition tests
 - Ignition power : 100 – 150 mW
 - Ignition time : 20 – 130 ms
 - Combustion time : ~ 320 ms



Conclusions

- Turn ideas into demonstrators
- Advance the technology base
- Encourage start-up initiatives
 - Seyonic (1998), Sercalo Microtechnology (1999), NanoWorld (2000),...
- Encourage technology transfer
 - Intersema (pressure sensors), MicroFlow Engineering (Inhalers), CSEM, Colibrys, ...

Recent Start-up Companies

Sercalo Microtechnology SA

Production of Optical MEMS Switches and Attenuators



Seyonic SA

Engineering and manufacturing of microfluidic devices and systems for life sciences and space research



NanoWorld SA

Nanotools for Scanning Probe Microscopy



Remerciements

- Les Autorités de la République et du Canton de Neuchâtel et l'Université de Neuchâtel
- Les membres de SAMLAB
- Le CSEM S.A.
- L'ESA GSTP/AST et l'ESA PRODEX
- Le comité pour la technologie et l'innovation (CTI)
 - M²S², MedTech.
- Le Conseil des Ecoles polytechniques fédérales
 - MINAST, Optics, TOP NANO 21.
- Fond national suisse de la recherche scientifique
- Office fédéral de l'éducation et de la science